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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Kun Yul KIM
Appl. No. : 10/787,106
Filed : February 27, 2004
Title : Apparatus And Method For Controlling Tracking And
Focusing Servo In A Holographic Digital Data Storage
System

TC/A.U. : 2652
Examiner : Unknown

Docket No.: : KIMK3009/EM
Customer No: : 23364

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

INFORMATION DISCLOSURE STATEMENT

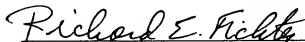
Sir:

Pursuant to Rule 37 C.F.R. §1.51(b), §1.56, §1.97, and §1.98, this Information Disclosure Statement is submitted in the above-identified patent application. A listing of documents to be published on the face of any patent granted from this application is submitted herewith on Form PTO-1449. Any other documents or information submitted for consideration by the Examiner are listed in this paper.

The Examiner is requested to acknowledge consideration of the information provided in this paper in accordance with prescribed procedures.

Please charge any additional fees or credit any overpayments in connection with this paper to Deposit Account No. 02-0200.

Respectfully submitted,


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Date: September 22, 2005

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PATENT & TRADEMARK OFFICE

B/O Foreign Patent No. 10-1449 U.S. Department of Commerce Patent and Trademark Office Information Disclosure Statement by Applicant	Atty. Docket Number	Serial Number
	KIMK3009/EM	10/787,106
	Applicant Kun Yul KIM	
Filing Date	Group	
February 27, 2004	2652	

U.S. Patent Documents

Examiner Initial	Document Number	Date	Patentee/Applicant	Class	Subclass	Filing Date if Appropriate

Foreign Patent Documents

Examiner Initial	Document Number	Publication Date	Country/Agency	Class	Subclass	Translation	
						Yes	No
	2002-063729 (w/English Abstract)	02/28/2002	JP				X
	5-151593 (w/English Abstract)	06/18/1993	JP				X

Other Documents (Including Author, Title, Date, Pertinent Pages, Place of Publication, Etc.)

Examiner	Date Considered

EXAMINER: Initial if citation is considered, whether or not citation is in conformance with MPEP 609; Draw a line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.